

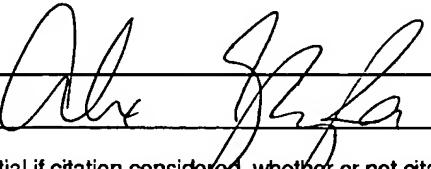
FORM HDP-1449 (Based on Form PTO-1449)		ATTORNEY DOCKET NO.	SERIAL NO.
PATENT AND TRADEMARK OFFICE INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)		9319S-000311/CPA	10/006,794
Sheet 1 of 1		APPLICANT	
		Hitoshi FUKUSHIMA	
		FILING DATE	GROUP
		December 4, 2001	2812

U.S. PATENT DOCUMENTS						
Ref. Desig.	Examiner's Initials	Document Number	Date	Name	Class/ Subclass	(If appropriate) Filing Date
1.						

FOREIGN PATENT DOCUMENTS						
Ref. Desig.	Examiner's Initials	Document Number	Date	Country	Class/ Subclass	Translation * Yes No
1.	AC	10-217457A	08/18/1998	Japan		X
2.		99/038695	08/05/1999	WO		X
3.		11-15000	01/22/1999	Japan		X
4.	AC	8-88402	04/02/1996	Japan		X

OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, etc.)						
Ref. Desig.	Examiner's Initials					
1.	AC	H. Fukushima and 2 others, "Microstructure, Wettability, and Thermal Stability of Semifluorinated Self-Assembled Monolayers (SAMs) on Gold" J. Phys. Chem. B 2000, 104, pp. 7417-7423				
2.	AC	Notification of Reasons of Rejection dated June 8, 2005 in corresponding Japanese application No. JP2001-370544.				

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Examiner:  Date Considered: 7/16/06

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